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Microelectronic Spring Structures  
On A Substrate  
First Named Inventor: Benjamin Eldridge  
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Disclosure Statement

Application Number: 09/781,833

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## Method For Forming Microelectronic Spring Structures On A Substrate

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### Attached Files:

us-information-disclosure-statement

P109-USids.xml

**Comments:**

Listed in this Information Disclosure Statement (IDS) are references known to Applicants. The filing of this IDS should not be taken as a representation that a search has been made or that the references cited in this IDS are, or are considered to be, prior art or material to patentability.